



033082 M 277

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Takanori Saito, et al.

Serial No.: 10/551,033

Art Unit: Not Yet Assigned

Filed: September 27, 2005

Examiner: Not Yet Assigned

For: THERMAL PROCESSING METHOD AND THERMAL PROCESSING UNIT

THIRD INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to the duty of disclosure under 37 C.F.R. 1.56, Applicants are enclosing an Information Disclosure Citation Form (PTO-1449) which lists the references cited in the attached Japanese Office Action dated November 20, 2006. Copies of the references are also enclosed.

Each item of information contained in this Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Information Disclosure Statement.

It is respectfully requested that the cited documents be considered by the Examiner in the above-identified patent application and that the cited documents be made officially of record therein. It is further requested that a listing of the same appear on the face of any patent which may issue from this application.

Respectfully submitted,
SMITH, GAMBRELL & RUSSELL, LLP

By:

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Date: December 11, 2006



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| FORM PTO-1449 INFORMATION DISCLOSURE STATEMENT | ATTY. DOCKET 033082 M 277 | SERIAL NO. 10/551,033 |
| | APPLICANT: Takanori SAITO, et al. | |
| | FILING DATE September 27, 2005 | GROUP ART UNIT To Be Assigned |

U.S. PATENT DOCUMENTS

| *Examiner's Initials | | DOCUMENT NUMBER | DATE | NAME | CLASS | SUB- CLASS | FILING DATE, IF APPROPRIATE |
|-------------------------|----|--------------------|------|------|-------|---------------|--------------------------------|
| | AA | | | | | | |
| | AB | | | | | | |
| | AC | | | | | | |
| | AD | | | | | | |
| | AF | | | | | | |
| | AG | | | | | | |
| | AH | | | | | | |
| | AI | | | | | | |
| | AJ | | | | | | |
| | AK | | | | | | |

FOREIGN PATENT DOCUMENTS

| *Examiner's Initials | | DOCUMENT NUMBER | DATE | COUNTRY | CLASS | SUB- CLASS | TRANSLATION YES NO | |
|-------------------------|----|--------------------|----------|---------|-------|---------------|-----------------------|--|
| | AL | 2001-176810 | 6/29/01 | Japan | | | Abstract | |
| | AM | 2002-373890 | 12/26/02 | Japan | | | Abstract | |
| | AN | | | | | | | |
| | AO | | | | | | | |
| | AP | | | | | | | |

OTHER INFORMATION (Including Author, Title, Date, Pertinent Pages, Etc.)

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| | AQ | |
| | AR | |
| | AS | |
| EXAMINER: | | DATE CONSIDERED: |
| <small>*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</small> | | |